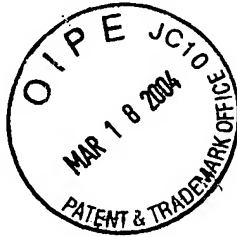


Serial No. 10/063,094

May 29/2
Docket No. RD-27190-3 *1762*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Barry Lee-Mean Yang



Serial No.: 10/063,094

Group Art Unit: 1762

Filed: March 19, 2002

Examiner: T. Meeks

For: APPARATUS AND METHOD FOR LARGE
AREA CHEMICAL VAPOR DEPOSITION
USING MULTIPLE EXPANDING THERMAL
PLASMA GENERATORS

PETITION AND FEE FOR EXTENSION OF TIME (37 CFR 1.136(a))

This is a petition to extend the time for response to the Office Action mailed November 14, 2003
by one month from February 14, 2004 to March 14, 2004

EXTENSION FEE			
Months	Fee	Deduction for Prior Extension	Net Fee
One	\$110.00	0.00	110.00
Two	\$420.00	0.00	0.00
Three	\$950.00	0.00	0.00
Four	\$1,480.00	0.00	0.00
Five	\$2,010.00	0.00	0.00
Total Fee			\$110.00

Please charge the fee in the amount of \$110.00, Deposit Account No. 07-0868. The Assistant Commissioner is authorized to charge any additional fees required under 37 CFR 1.16 or 1.17, and to credit any overpayment, to Deposit Account No. 07-0868. This petition is submitted in triplicate.

Respectfully submitted,

Tanzina Chowdhury

Date 3/13/04

Schenectady, New York

Attorney Tanzina S. Chowdhury

Registration No.: 46,624

Telephone No.: 518 387-7166
or (518) 387-7122

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